

APPROVED

APPROVED: /K.P./

/Hsien-ming Lee/
Primary Examiner

DOCKET NO: 285995US26PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
KOHEI KAWAMURA, ET AL. : EXAMINER: KEVIN A. PARENDO
SERIAL NO: 10/567,733 :
FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823
FOR: FLUORINE DOPED CARBON :
FILMS PRODUCED BY
MODIFICATION BY RADICALS

PETITION TO CORRECT INVENTIVE ENTITY UNDER 37 C.F.R. § 1.48(a)

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

This Amendment and Petition under 37 C.F.R. § 1.48(a) is to delete the names of the following persons originally named as inventors in the above-identified patent application in error and without deceptive intent. The names of the inventors to be deleted are:

Kohei KAWAMURA; and
Yasuo KOBAYASHI.

The correct inventors of the present application are:

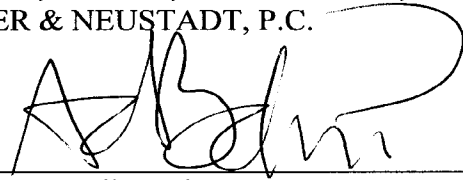
Kenichi NISHIZAWA;
Yasuhiro TERAJ; and
Akira ASANO.

Applicants submit herewith a processing fee set forth in § 1.17(i) and Substitute Declaration and Supplemental Application Data Sheet under separate cover for the purpose of correcting the above inventorship.

Accordingly, Applicants request the correction to the inventive entity be entered and the Petition granted.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

A handwritten signature in black ink, appearing to read 'S. Weihrouh', written over a horizontal line.

Steven P. Weihrouh
Attorney of Record
Registration No. 32,829

Customer Number
22850

Tel: (703) 413-3000
Fax: (703) 413 -2220
(OSMMN 08/07)

SPW/AHB/yst

Adnan H. Bohri
Registration No. 62,648

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SERIAL NO: 10/567,733 :
FILED: FEBRUARY 10, 2006 : GROUP ART UNIT: 2823
FOR: METHOD FOR FORMING FILM, :
METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT
SYSTEM

STATEMENT OF INVENTOR TO BE DELETED

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

I, Kohei KAWAMURA, a named inventor for U.S. Patent Application Serial No.
10/567,733, state the following:

1. I should be deleted from inventors for U.S. Patent Application Serial No.
10/567,733;
2. My addition to the original declaration was an error; and
3. The error arose without any deceptive intention on my part.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Dated: October 1, 2009

Kohei Kawamura
Kohei KAWAMURA

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SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT
SYSTEM

STATEMENT OF INVENTOR TO BE DELETED

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

I, Yasuo KOBAYASHI, a named inventor for U.S. Patent Application Serial No.
10/567,733, state the following:

1. I should be deleted from inventors for U.S. Patent Application Serial No.
10/567,733;
2. My addition to the original declaration was an error; and
3. The error arose without any deceptive intention on my part.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Dated: October 1, 2009



Yasuo KOBAYASHI

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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

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FOR: METHOD FOR FORMING FILM, :
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SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT
SYSTEM

STATEMENT OF ASSIGNEE

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

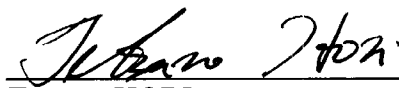
I, TOKYO ELECTRON LIMITED, the assignee of the entire interest of U.S. Patent
Application Serial No. 10/567,733, state the following:

1. The inventors of U.S. Patent Application Serial No. 10/567,733 are Kenichi
NISHIZAWA, Yasuhiro TERAII, and Akira ASANO.
2. The originally named inventors, Kohei KAWAMURA and Yasuo KOBAYASHI
should be deleted as inventors in U.S. Patent Application Serial No. 10/567,733.
3. The error arose without any deceptive intention on the part of the assignee.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Dated: October 1, 2009



Tetsuro HORI

Vice President & General Manager, Legal/Intellectual Property
TOKYO ELECTRON LIMITED